



Image

PATENT
8013-1089-3

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Kazuhiko ENDO

Conf. 6839

Application No. 10/017,396

Group 2813

Filed December 18, 2001

Examiner Y. Huynh

SILICA INSULATION FILM WITH A
REDUCED DIELECTRIC CONSTANT AND
METHOD OF FORMING THE SAME

RESPONSE

Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

March 10, 2004

Sir:

This replies to the Official Action of February 13,
2004.

Remarks begin on page 2 of this paper.